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# Methods of Beam Emittance Measurements of High Power Negative Ion Beams for NBIs

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## High power negative ion beam for NBIs

#### JT-60SA

0.5 MeV, 22 A (130 A/m<sup>2</sup>) for 100s from three stage-multi aperture beam source



#### **ITER project**

1 MeV, 40 A (200 A/m<sup>2</sup>) for 3600 s from five stage and multi aperture beam source





#### MeV ion source Test Facility (MTF) in QST

The test facility is developing the ion beam accelerator for the ITER NBI system.

#### **ITER REQUIREMENTS:**

Beam Energy : 1 MeV Beam Current : 40 A Current Density : 200 A/m<sup>2</sup> (D<sup>-</sup>) Pulse Length : 3600 s

#### **MTF** specification

Beam Energy : 1 MeV Beam Current : 1 A Current Density : 200 A/m<sup>2</sup> (H<sup>-</sup>) Pulse Length : > 1000 s



MTF Facility in Naka Fusion Institute, Ibaraki



### Recent issues and solutions



Degradation of current for long pulse

- $\rightarrow$  Temperature control of chamber wall to suppress excess
- Cs deposition from wall to plasma grid (Dr. Yoshida (P1-09))

Negative ion acceleration

High power loading on acceleration grids due to beam deflection by magnetic field and space charge repulsion  $\rightarrow$  Compensated

Insufficient voltage holding capability of large accelerator  $\rightarrow$  Construction of experimental scaling to design large grid with multi apertures

Beam acceleration up to 60 s has been achieved.

Beam acceleration over 100 s is now on-going.

Aperture displacement

Cs

ement plate

Field shaping

Beam \_\_\_\_\_



#### **Recent results**



However, precise study for this kind of high dense and large beams has not been performed yet.

### Beam Diagnostics for 1 MeV High current density Beams

#### **Common Measurement Methods:**

#### **Slit-and-Collector Method**

Faraday cups and wire scanners.



Things to consider: electrical noise (i.e. secondary electrons) sensitivity/resolution

#### Imaging methods

Fluorescence due to particle beams.

Things to consider: lifetime of scintillator screens







## **Thermal Measurement of Beam Emittance**

**Target Material** 

A one-dimensional carbon fiber composite (CFC) target is selected to measure the high power beam.

• High heat resistance

(Melting Point: 2000°C)

- Good machining properties
- Low axial thermal conductivity
- Imaging form of measurement



Low axial conductivity reduces the overestimation of the beam size.

Material	Thermal Expansion Coefficient (linear)	Melting Point (°C)	Density (kg/m³)	Specific Heat (J/kg K)
1D-CFC	2.95	2000	1660	1140
Cu	16.7	1085	8960	376.8
W	4.5	3410	19600	133.9
Мо	5	2623	10188	277.1



# **Thermal Measurement of Beam Emittance**

**Target Material** 

Previous thermal images that captured the beam footprint of a 1 MeV negative ion beam exhibited a Gaussian profile with the beam power density averaging to 200 MW/m<sup>2</sup>.

Calculation of a Gaussian profile beam Total Beam Power Density in 1D



Beam Divergence : 5 mrad Drift distance: 2.3 m Aperture diameter: 14 mm



Beam Power Density (MW/m<sup>2</sup>) Spatial contour of the Gaussian beam The exposure time of the beam to the CFC target will be limited when reproducing the beam footprint.

#### **Material Parameters:**

- Thickness /
  Dimensions
- Exposure time
- Thermal Expansion



### Operation of the 1 MeV Negative Ion Beam



83.8

21.9



### **Operation of the 1 MeV Negative Ion Beam**

**Beam Profile** 



Sampling Rate: 120 Hz Beam Pulse: 0.2 sec

Broadening of the beam footprint at longer exposure times.

Tune to the stable beam operation

The multiple beamlet profiles of a 900 keV negative hydrogen ion beam was observed through the thermal images on the CFC target.



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# Operation of the 1 MeV Negative Ion Beam

**Beam Profile** 

Thermal images show the multiple beamlets.

Noise from the background temperature in the images were reduced.

Displacement on the beamlet alignment

Possible reasons:

- Initial particle trajectories upon extraction
- Non-uniformity in the beam initializing phase





### Operation of the 1 MeV Negative Ion Beam

**Beam Profile** 





### Diagnostics for 1 MeV Negative Ion Beam

Beam Emittance Application





### **Diagnostics for 1 MeV Negative Ion Beam**

#### Measurement Schemes

Parc

Vext

IH<sup>-</sup>

To assure that the measured beam is stable, the ion source will operate continuously.



Possible mechanisms for continuous beam monitoring.



# Summary

1 MeV High Power Beam

**High Beam Power Densities** 



Thermal Beam Emittance Measurement Method

1D – Carbon-Fiber Composite

#### **Challenge for Beam Diagnostics :**

High voltage components of the accelerator High temperature heat loading (Long) Beam Pulse Operation

#### Advantages:

Imaging form of measurement CFC has a high heat resistance Measurement schemes are possible

Beam diagnostics of the 1MeV H<sup>-</sup> beam is possible with the thermal beam emittance measurement. This method is being developed specifically for ITER class beams for NBI systems



## Thank you for your attention